X-STREAM Enhanced

XEGP - General Purpose Gas Analyzer

- Up to five component gas analyzer featuring NDIR/UV/VIS photometer, paramagnetic and electrochemical O₂, thermal conductivity, and moisture sensors
- Enhanced performance with IntrinzX technology
- Modern communication capabilities including web-browser functionality
- Outstanding reliability with a three-year warranty



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Features

The X-STREAM *Enhanced* full 19" general purpose analyzer combines powerful analytical technology with modern communication functionality to face your analytical problem.

Analytical Flexibility

The X-STREAM platform enables the combination of up to five channels of non-dispersive infrared, ultraviolet, visible photometers (NDIR/UV/VIS), thermal conductivity (TCD), trace moisture (tH_2O), paramagnetic and electrochemical oxygen (pO_2/eO_2) detectors.

Enhanced Performance

With the X-STREAM photometer technology, the analyzer provides a measuring accuracy that allows improving your process while also reducing the total cost of ownership by:

- Large dynamic ranges
- Very low temperature dependency
- Outstanding long-term stability
- Simplified calibration

Three-Year Warranty

All important parts and the complete analyzer are run through a variety of test procedures, including long-term stability and temperature behavior. This enables us to provide a three-year warranty for the analyzer, excluding sample-wetted parts and externally connected electronics.

Modern Communication

The X-STREAM *Enhanced* offers a unique web-browser interface that features:

- World wide access through the internet without installation of additional software
- E-mail notification on alarms and events or with daily report
- Complete remote configuration

X-STREAM *Enhanced* analyzers provide four status signal relay outputs (according to NAMUR NE 107), MODBUS TCP protocol over Ethernet and RTU over serial (RS232/485) communication. Onboard SD card and USB ports enable storage of:

- Data, calibration and event logger files
- Analyzer configuration file

A pre-engineered DeltaV module features easy integration into your DeltaV environment via ModbusRTU over serial interface. ProfibusDP is also supported by a ModbusRTU-ProfibusDP gateway.

Tools

The X-STREAM *Enhanced* analyzer software provides several tools that make complex process systems easier and avoid additional expenses for third-party equipment:

- Programmable Logic Controller (PLC) for control of sample handling and sample lines
- Calculator for virtual measurements
- Analog inputs for integrating external measurements into the powerful X-STREAM *Enhanced* environment





Ease of Use

The instrument has an graphic display and is operated manually by six keys. Clear text messages (available in several languages) and industry-standard symbols provide information about the measurement and the analyzer status.

Options in a 19" Enclosure

- Sample gas pump
- Flow measurement with alarm
- Valve block
- Pressure sensor
- Digital Input/Output cards
- Analog input card

Worldwide Approvals

CE, CSA-C/US and C-Tick approvals allow global installation of X-STREAM general purpose analyzers.

Applications

- Gas purity and air separation units
- Biogas and landfill
- Automotive emissions (ICE)
- Continuous Emission Monitoring Systems (CEMS)

<image><image>

Web browser showing measured concentrations and secondaries.

Process-approved Sensors

Solvent-resistant, corrosion-resistant, intrinsically safe, and infallible containment solutions are available.

- Exhaust measurements for burner efficiency
- Natural gas production and distribution
- Metal hardening
- Oil and gas refining



Interior view, showing four NDIR benches, thermostat control (cover removed), analog and relay outputs, digital inputs, serial interface and screw terminals option.



The enlarged graphic display of the X-STREAM Enhanced provides measurement and status information with plain text and symbols.

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Rear side view (incl. two optional digital I/O boards)

Specifications

Lowest and Highest Ranges Available for Different Gases (Excerpt)

In total, the X-STREAM family of process gas analyzers can detect more than 60 gases. The following table is an example of the most commonly used gases. Contact your Emerson representative for information on configurations or gases that are not listed.

Table 1	Gas Com	ponents and	Measuring	Ranges.	Examples
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		Special Specs or Conditions	Standard Specs (Table 2 – 4)	Enhan (Tab	ced Specs le 2 & 4)	
Gas component		Principle	Lowest Range	Lowest Range	Lowest Range	Highest Range
Acetone ¹	CH ₃ COCH ₃	UV		0–400 ppm	0–800 ppm	0–3 %
Acetone ¹	CH ₃ COCH ₃	IR		0–500 ppm	0–1000 ppm	0–3 %
Acetylene	C_2H_2	IR		0–3 %	0–6 %	0–100 %
Ammonia	NH_3	IR		0–100 ppm	0–200 ppm	0-100 %
Argon	Ar	TCD		0-50%	0-100 %	0–100 %
Carbon dioxide	CO ₂	IR	0–5 ppm ⁵	0–50 ppm	0–100 ppm	0–100 %
Carbon monoxide	CO	IR	0–10 ppm ⁵	0–50 ppm	0–100 ppm	0–100 %
Chlorine	Cl ₂	UV		0–300 ppm	0–600 ppm	0–100 %
Ethane	C ₂ H ₆	IR		0–1000 ppm	0–2000 ppm	0–100 %
Ethanol ¹	C ₂ H ₅ OH	IR		0–1000 ppm	0–2000 ppm	0–10 %
Ethylene	C_2H_4	IR		0–400 ppm	0–800 ppm	0–100 %
Helium	He	TCD		0-10%	0–20 %	0-100 %
Hexane ¹	C_6H_{14}	IR		0–100 ppm	0–200 ppm	0–10 %
Hydrogen ⁴	Η,	TCD		0–1 %	0–2 %	0–100 %
Hydrogen Sulfide	H_2S	UV		0–2 %	0-4 %	0–10 %
Hydrogen Sulfide	H₂S	IR		0-10%	0–20 %	0–100 %
Methane	CH_4	IR		0–100 ppm	0–200 ppm	0–100 %
Methanol ¹	CH ₃ OH	IR		0–1000 ppm	0–2000 ppm	0–10 %
n–Butane	C_4H_{10}	IR		0–800 ppm	0–1600 ppm	0-100 %
Nitrogen dioxide ¹	NO ₂	UV	0–25 ppm ³	0–100 ppm	0–200 ppm	0–10 %
Nitrogen monoxide	NO	IR	0–100 ppm ³	0–250 ppm	0–500 ppm	0–100 %
Nitrous oxide	N_2O	IR		0–100 ppm	0–200 ppm	0–100 %
Oxygen	02	Electrochem.		0–5 %	-	0-25 % 26
Oxygen	02	Paramagn.		0–1 %	0–2 %	0–100 %
Oxygen, Trace	02	Electrochem.		0–10 ppm	-	0–10 000 ppm ⁶
Propane	$C_{3}H_{8}$	IR		0–1000 ppm	0–2000 ppm	0–100 %
Propylene	C_3H_6	IR		0–400 ppm	0–800 ppm	0–100 %
Sulfur dioxide	SO ₂	UV	0–25 ppm ³	0–130 ppm	0–200 ppm	0–1 %
Sulfur dioxide	SO ₂	IR		0–1 %	0-2 %	0-100 %
Sulfur hexafluoride	SF_6	IR	0–5 ppm ³	0–20 ppm	0–50 ppm	0–2 %
Toluene 1	C ₇ H ₈	UV		0–300 ppm	0–600 ppm	0–5 %
Vinyl chloride	C ₂ H ₃ Cl	IR		0–1000 ppm	0–2000 ppm	0–2%
Water vapor ¹	H ₂ O	IR		0–1000 ppm	0–2000 ppm	0-8 %
Water vapor, Trace ¹	H,O	Capacitive		0–100 ppm	_	0–3000 ppm ⁶

¹ Dew point below ambient temperature

² Higher concentrations decrease sensor lifetime

Daily zero calibration: Required for ranges below lowest standard specs range

3

Special "refinery" application5see Table 5with 0-1 % H2 in N2 available6Standard special special

⁶ Standard specs only

Standard and Enhanced Performance Specifications

Table 2 IR/UV/VIS, TCD – Standard and Enhanced Measurement Performance Specifications

	NDIR/UV/VIS		Thermal Conductivity (TCD)	
	Standard Spec	Enhanced Spec	Standard Spec	Enhanced Spec
Detection limit (4 σ) ¹⁴	≤ 1 %	≤ 0.5 %	≤ 1 %	≤ 0.5 %
Linearity ¹⁴	≤ 1	%	≤ 1 %	
Zero-point drift ^{1 4}	≤ 2 % per week	≤ 1 % per week	≤ 2 % per week	≤ 1 % per week
Span (sensitivity) drift ¹⁴	≤ 0.5 % per week	≤ 1 % per month	≤ 1 % per week	
Repeatability ¹⁴	≤ C	.5 %	≤ C	0.5 %
Response time (t ₉₀) ³	4 s ≤ t _c	₉₀ ≤ 7 s ⁵	$15 \text{ s} \le t_{90} \le 30 \text{ s}^{-6}$	
Permissible gas flow	0.2–1.	5 l/min.	0.2–1.5 l/min. ¹¹	
Influence of gas flow ¹⁴	≤ C	.5 %	≤ 1 % ¹¹	
Maximum gas pressure ⁸	≤ 1500 hPa abs. (≤ 7 psig)		≤ 1500 hPa abs. (≤ 7 psig)	
Influence of pressure ²				
 At constant temperature 	≤ 0.10 % per hPa		≤ 0.10 % per hPa	
– With pressure compensation ⁷	compensation ⁷ \leq 0.01 % per hPa		≤ 0.01 % per hPa	
Permissible ambient temperature ⁹	0 to +50 °C	(32 to 122 °F)	0 to +50 °C (32 to 122 °F)	
Influence of temperature ¹¹³				
(at constant pressure)		1		1
– On zero point	≤ 1 % per 10 K	≤ 0.5 % per 10 K	≤ 1 % per 10 K	≤ 0.5 % per 10 K
– On span (sensitivity)	\leq 5 % (0 to +50 °C / 32 to 122 °F)		≤1%	per 10 K
Thermostat control ⁶¹²	none / 60	°C (140 °F) ⁵	none / 60 °C (140 °F) 10	
Warm-up time ⁶	15 to 50 minutes ⁵		approx. 5	50 minutes

¹ Related to full scale

² Related to measuring value

 ³ From gas analyzer inlet at gas flow of 1.0 l/min (electronic damping = 0 s)

⁴ Constant pressure and temperature

 $^{\scriptscriptstyle 5}\,$ Dependent on integrated photometer bench

⁶ Depending on measuring range

⁷ Pressure sensor is required

⁸ Limited to atmospheric if internal sample pump ⁹ Temperatures below 0 °C (-4 °F) with thermostat control only Note! 1 psi = 68.95 hPa

 10 Thermost. controlled sensor: 75 °C (167 °F)

¹¹ Flow variation within ± 0.1 l/min

¹² Optional thermostat controlled box with temperature 60 °C (140 °F)

¹³ Temperature variation: \leq 10 K per hour

Table 3 Trace Moisture – Standard Measurement Performance Specifications

	Trace Moisture (tH ₂ O)
Measurement range	-100 to -10 °C dew point (0–1003000 ppm)
Measurement accuracy	±2 °C dew point
Repeatability	0.5 °C dew point
Response time (t ₉₅)	5 min (dry to wet)
Operating humidity	0 to 100 % r.h.
Sensor operating temperature	-40 to +60 °C
Temperature coefficient	Temperature compensated across operating temperature range
Operating pressure	Depending on sequential measurement system, see analyzer specification ¹
	max. 1500 hPa abs/7 psig ²
Flow rate	Depending on sequential measurement system, see analyzer specification ¹
	0.2 to 1.5 l/min

¹ If installed in series to another measurement system, e. g. IR channel

Note! 1 psi = 68.95 hPa

Table 4 Oxygen – Standard and Enhanced Measurement Performance Specifications

	Oxygen Sensors			
	Paramagnetic (pO ₂)		Electrochemical (eO ₂)	Trace (tO ₂)
	Standard Spec	Enhanced Spec		
Detection limit (4 σ) ^{1 4}	≤1%	≤ 0.5 %	≤1%	≤1%
Linearity ¹⁴	≤	1%	≤ 1 %	≤ 1 %
Zero-point drift ^{1 4}	≤ 2 % per week	≤ 1 % per week	≤ 2 % per week	≤ 1 % per week
Span (sensitivity) drift ¹⁴	≤ 1 % per week	≤ 0.5 % per week	≤ 1 % per week	≤ 1 % per week
Repeatability ¹⁴	≤ 0).5 %	≤ 1 %	≤ 1 %
Response time (t ₉₀) ³	<	5 s	approx. 12 s	20 to 80 s
Permissible gas flow	0.2–1	.5 l/min	0.2–1.5 l/min.	0.2–1.5 l/min.
Influence of gas flow ¹⁴	≤ 2 % ¹⁰		≤ 2 %	≤ 2 %
Maximum gas pressure ⁷	≤ 1500 hPa abs. (≤ 7 psig) ¹³		≤ 1500 hPa abs. (≤ 7 psig)	≤ 1500 hPa abs. (≤ 7 psig)
Influence of pressure ²				
 At constant temperature 	≤ 0.10 % per hPa		≤ 0.10 % per hPa	≤ 0.10 % per hPa
 – With pressure compensation ⁶ 	≤ 0.01 % per hPa		≤ 0.01 % per hPa	≤ 0.01 % per hPa
Permissible ambient temperature ⁸	0 to +50 °C	(32 to 122 °F)	5 to +45 °C (41 to 113 °F)	5 to +45 °C (41 to 113 °F)
Influence of temperature ^{1 12}				
(at constant pressure)	1 % por 10 K	0 E % por 10 K	1 % por 10 K	- 1 % por 10 K5
- On zero point	\leq 1% per 10 K \leq 0.5% per 10 K		$\leq 1\%$ per 10 K	$\leq 1\%$ per 10 K ²
– On span (sensitivity)	<u>≤ 1 /o</u>	1 40 05\ 11	≤ 1 % per 10 K	≤ 1 % per 10 K ³
I nermostat control	60°C(140°F)''	none	none ³
Warm-up time	Approx.	50 minutes	-	Approx. 50 minutes
				Note! 1 psi = 68.95 hPa

Related to full scale
 Related to measuring value

(electronic damping = 0 s)

⁴ Constant pressure and temperature

5 Range 0–10...200 ppm: ≤ 5 % (5 to 45 °C /

³ From gas analyzer inlet at gas flow of 1.0 l/min

⁶ Pressure sensor is required

⁷ Limited to atmospheric if internal sample pump

⁸ reserved for future use

⁹ Thermost. controlled sensor: 35 °C (95 °F)

¹⁰ For ranges 0–5...100 % and flow 0.5...1.5 l/min

······

¹¹ Optional thermostat controlled sensor with tempe-

rature 60 °C (140 °F)

¹² Temperature variation: \leq 10 K per hour

¹³ No sudden pressure surge allowed

Note 1!

41 to 113 °F)

Not all data listed are applicable to all analyzer versions (e.g. 60 °C thermostat controlled box is not available for electrochemical and trace oxygen).

Note 2!

For NDIR/UV/VIS measurements, take into account that sample gas may diffuse or be released by leakages into the analyzer enclosure. If existent in the analyzer surroundings, the component to be measured may enter the enclosure. Concentrations then may increase inside the enclosure. High concentrations of the component to be measured inside the enclosure may influence the measurement by unintended absorption, which could cause drift of the measurement. A remedy for this issue is to purge the housing with gas not containing the component of interest.

Note 3!

Measurement principles or composition of sample gas may limit the available options for a specific analyzer configuration concerning e. g. sample handling options or tubing materials.

Special Performance Specifications for Gas Purity Measurements (ULCO & ULCO₂)

Table 5 Special Performance Specifications for Gas Purity Measurements

	0–10<50 0–5<50) ppm CO ppm CO ₂
Detection limit $(4 \sigma)^{12}$	< 2	2 %
Linearity ^{1 2}	< 1	%
Zero-point drift ¹²³	< 2 % resp. •	< 0.2 ppm ⁹
Span (sensitivity) drift ^{1 2 4}	< 2 % resp. •	< 0.2 ppm ⁹
Repeatability ^{1 2}	< 2 % resp. •	< 0.2 ppm ⁹
Response time (t ₉₀) ⁷	<1	0 s
Permissible gas flow	0.2–1.5	5 l/min.
Influence of gas flow ^{1 2}	< 2 %	
Maximum gas pressure ¹⁰	≤ 1500 hPa abs. (≤ 7 psig)	
Influence of pressure ⁵		
– At constant temperature	≤ 0.1 %	per hPa
 – With pressure compensation ⁸ 	≤ 0.01 %	per hPa
Permissible ambient temperature	+15 to +35 °C (59 to 95 °F)	+5 to +40 °C (41 to 104 °F)
Influence of temperature ⁶ (at constant pressure)		
– On zero point	< 2 % per 10 K resp. < 0.2 ppm per 10 K ⁹	
– On span (sensitivity)	< 2 % per 10 K resp. < 0.2 ppm per 10 K 9	
Thermostat control	none	60 °C (140 °F)

¹ Related to full scale

⁵ Related to measuring value

² Constant pressure and temperature

⁶ Temperature variation: ≤ 10 K per hour
 ⁷ From gas analyzer inlet at gas flow of 1.0 l/min

⁸ Barometric pressure sensor is required

Note! 1 psi = 68.95 hPa

⁹ Whichever value is higher

¹⁰ Limited to atmospheric if internal sample pump

³ Within 24 h; daily zero calibration requested ⁴ Within 24 h; daily span calibration recommended

General Specifications

Compliances	EN 61010-1, EN 61326, NAMUR, CSA-C/US, C-Tick
Gas Connections	PVDF: 6/4 mm; Stainless steel: 6/4 mm or 1/4"; for more options c.f.
Rated voltage	100–240 V∕, 50/60 Hz
Rated input current	3–1.5 A
Power input	IEC mains appliance
Signal Connections	Submin connectors or screw terminals; RJ45, USB
Enclosure Protection	IP 20 acc. EN 60529 for indoor installation, protected against direct sunlight
Humidity (non-condensing)	< 90 % r.h. @ 20 °C (68 °F) < 70 % r.h. @ 40 °C (104 °F)
Weight	Approx. 12–16 kg (26.5–35.3 lbs) depending on configuration
Options	Integrated flow measurement(s) with alarm(s), barometric pressure sensor, thermostatically controlled box for physical components (60 °C/140 °F), case purge, sampling pump(s) and/or solenoid valve block(s) for autocalibration

Signal In- & Outputs, Interfaces

Analog signal outputs:	1–5, individually optically isolated $4(0)$ –20 mA (R _B ≤ 500 Ω)
Relay outputs:	4 status relays acc. NAMUR NE 107 or e.g. concentration thresholds, valve status notification dry contacts: 1 A, 30 V $$
Communication interface:	Ethernet with Modbus TCP RS 485 / 232C with Modbus RTU 2 USB ports
Digital I/O (optional):	7/14 digital inputs (for remote control); max. 30V DC, 2.3 mA, common ground 9/18 additional relay outputs (e.g. concentration thresholds, valve status notification, flow alarm, range ID) dry contacts: 1 A, 30 V
Analog signal inputs (optional):	2 analog inputs $0-1(10) \vee (R_{i_n} = 100 \text{ k}\Omega) \text{ or}$ $4(0)-20 \text{ mA} (R_{i_n} = 50 \Omega)$

Dimensions



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